

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

EL 465780496

Priority Application Serial No. .... 09/030,618  
Priority Filing Date .... February 25, 1998  
Inventor .... Richard Holscher et al.  
Assignee .... Micron Technology, Inc.  
Priority Group Art Unit .... 1756  
Priority Examiner .... K. Duda  
Attorney's Docket No. .... MI22-1694  
Title: Semiconductor Processing Methods

**INFORMATION DISCLOSURE STATEMENT**

References -- See Attached Form PTO-1449


The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether the submitted references are prior art.

The listed references were cited by, or submitted to, the Office in the parent, co-pending application of the above-identified application. The above-identified application is a continuation of co-pending Application Serial No. 09/030,618, filed on February 25, 1998. Such prior disclosure is sufficient for the above-identified application as far as copies of the references are concerned.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 6-19-01

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